



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of

KATAGIRI et al.

Application Number: 10/081,212

Filed: February 25, 2002

For: **METHOD AND APPARATUS FOR
MANUFACTURING SEMICONDUCTOR DEVICE**

ATTORNEY DOCKET NO. NITT.0063

Unit 2812

Examiner
Roman, Angel

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TECHNOLOGY CENTER 2800

**Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231**

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Office Action dated December 20, 2002, the period for response to which will expire on January 20, 2003. Applicants hereby elect the continuing prosecution of Group I, Claims 1-11 and 17-19, without traverse.

REMARKS

The above election along with the following remarks are being submitted as a full and complete response to the Official Action dated December 20, 2002, the period for response to which will expire on January 20, 2003. The Examiner is respectfully requested to review the substance of Group I, Claims 1-11 and 17-19, and to indicate the allowability of the claims.

Claims 1-11 and 17-19 drawn to a method of making a semiconductor device have been elected in this application, while other claims are withdrawn from further prosecution without prejudice. Applicants hereby reserve the right to file a divisional application on any or all of the